Docket No. 241998US2S

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Yoshiaki FUKUZUMI

SERIAL NO: New Application GAU:

FILED: Herewith EXAMINER:

FOR: SEMICONDUCTOR MEMORY DEVICE COMPRISING MAGNETO RESISTIVE ELEMENT AND ITS

MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR

Applicant(s) wish to disclose the following information.

REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- □ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment form is enclosed herewith, or credit any overpayment to deposit account number <u>15-0030</u>. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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Form PTO 1449		U.S. DEPARTMENT OF	F COMMERCE	ATTY DOCKET NO.		SERIAL NO.		
(Modified)		PATENT AND TRADEMARK OFFICE		241998US2S	New Application			
				APPLICANT				
LIST OF REFERENCES CITED BY APPLICANT				Yoshiaki FUKUZUMI				
				FILING DATE		GROUP		
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U.S. PATENT DOCUMENTS								
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)								
Roy SCHEUERLEIN, et al., "A 10ns Read and Write Non-Volatile Memory Array Using a Magnetic Tunnel Junction and FET								
	AW	Switch in each Cell", 2000 IEEE International Solid-State Circuits Conference, Digest of Technical Papers, pgs. 128-129						
	AX	Masashige SATO, et al., "Spin-Valve-Like Properties of Ferromagnetic Tunnel Junctions", Jpn. J. Appl. Phys. Vol. 36 (1997) pp. L200-L201						
	AY							
	AZ				Additional References sheet(s) attached			
Examiner				Date Considered				
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								